

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Michial Duff Howell et al.

Application No.: NEW

Filed: HEREWITH

For: METHOD AND APPARATUS FOR
PREPARING SEMICONDUCTOR
WAFERS FOR MEASUREMENT

Group Art Unit: Unknown

Examiner: Unknown

PRELIMINARY AMENDMENT

121 Spear Street, Suite 290
San Francisco, CA 94105
(415) 512-1312

M/S PATENT APPLICATION
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examining the above-identified application, please enter the following amendments:

Amendments to the Specification begin on page 2 of this paper.

Amendment to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Arguments begin on page 5 of this paper.